

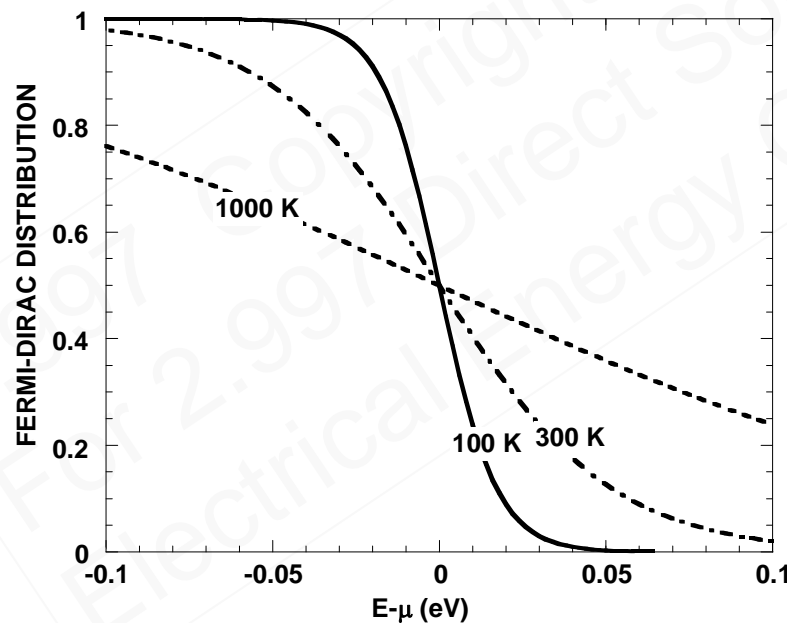
Lecture 6 Thermionic Engines

- Review
- Richardson formula
- Thermionic engines
- Schottky barrier and diode
- pn junction and diode
- discussion

Review: Fermi-Dirac Distribution

- Average number of electrons in the state

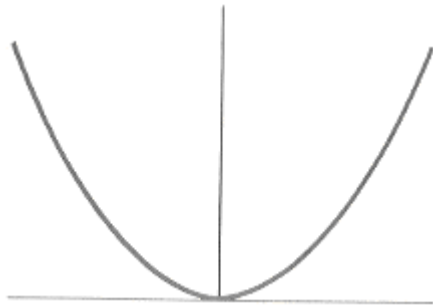
$$f = \sum_{n=0,1} n A e^{-(E-\mu)/(k_B T)} = \frac{1}{\exp\left(\frac{E-\mu}{k_B T}\right) + 1} \quad \text{Fermi-Dirac Distribution}$$



At $T=0\text{K}$, μ is called
Fermi level, E_f

$f=1$ for $E < \mu$
 $f=0$ for $E > \mu$

Review: Electron Density



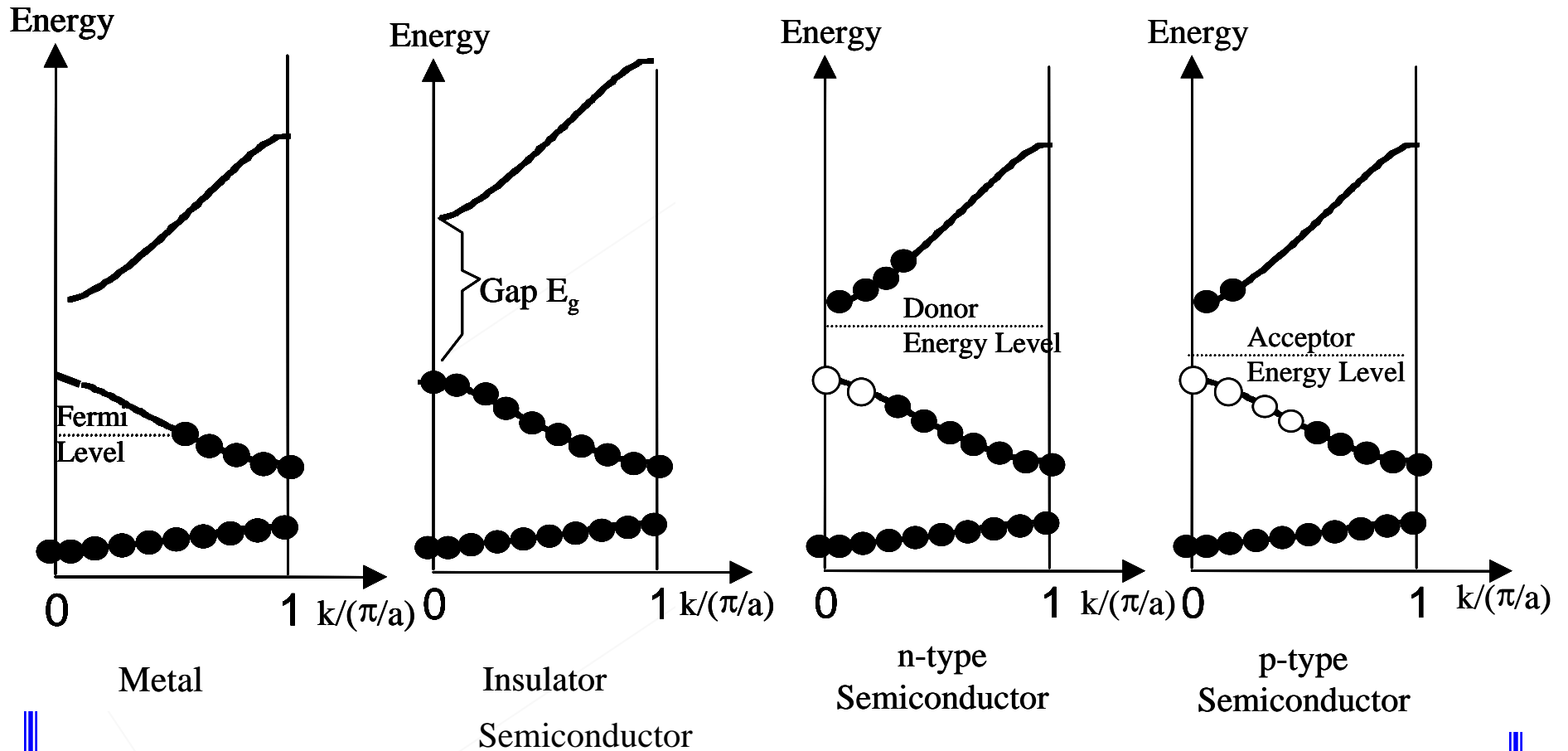
$$E - E_c = \frac{\hbar^2 (k_x^2 + k_y^2 + k_z^2)}{2m}$$

$$N = 2 \sum_{-N_x/2}^{N_x/2} \sum_{-N_y/2}^{N_y/2} \sum_{-N_z/2}^{N_z/2} f(E, T) = \frac{2V}{8\pi^3} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} dk_x dk_y dk_z \exp\left[-\frac{E - \mu}{k_B T}\right]$$

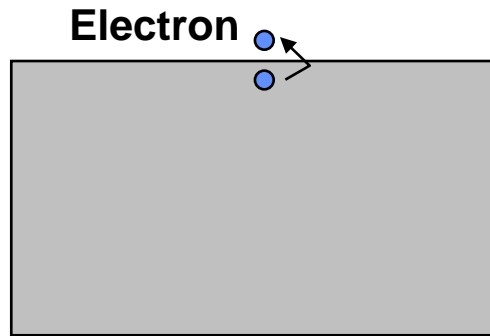
$$n = \int_{E_c}^{\infty} D(E) f(E, \mu, T) dE$$

$$n = 2 \left(\frac{2\pi m^* \kappa_B T}{h^2} \right)^{3/2} \exp\left(-\frac{E_c - \mu}{k_B T}\right) = N_c \exp\left(-\frac{E_c - \mu}{k_B T}\right)$$

Different Solids



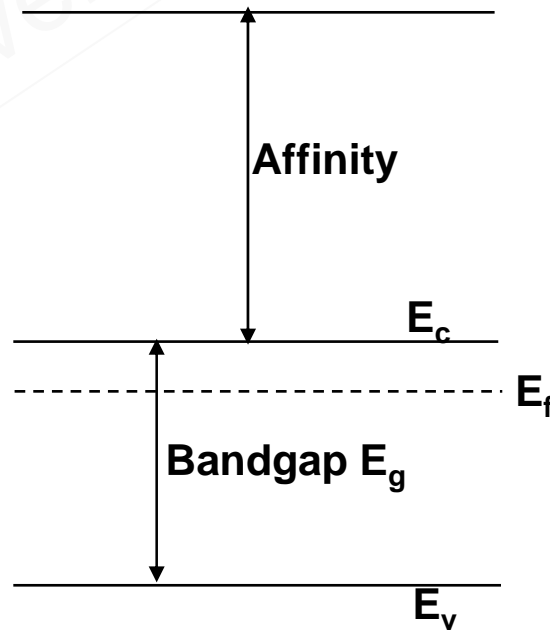
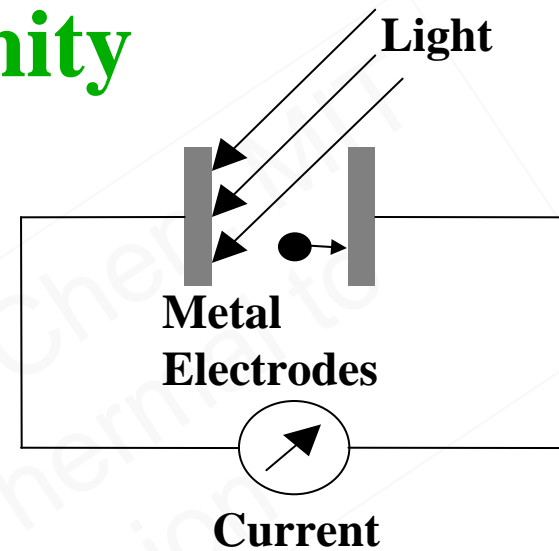
Work Function and Affinity



Vacuum

Work Function W

Fermi Level E_f



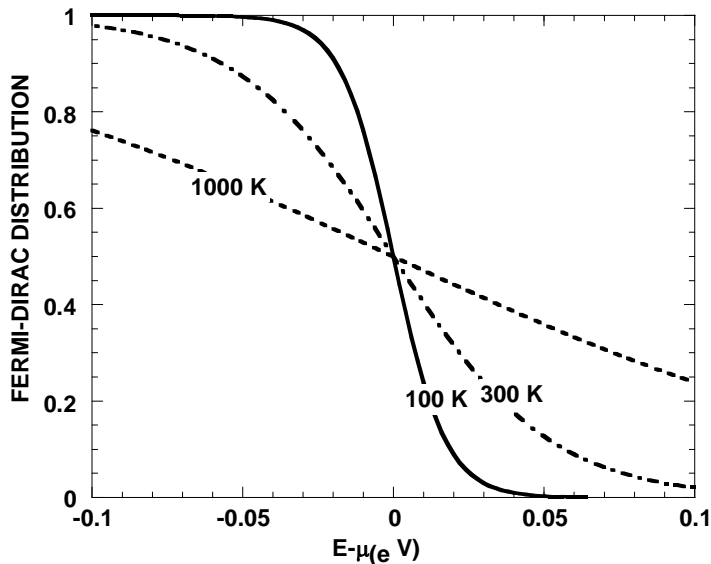
Vacuum **Electrons Just Outside the Metal**

$$E - \mu - W = \frac{\hbar^2 (k_x^2 + k_y^2 + k_z^2)}{2m}$$

Electron particle Flux Leaving Surface

$$J_p = \sum_{k_x > 0} \sum_{k_y = -\pi/a}^{\pi/a} \sum_{k_z = -\pi/a}^{\pi/a} v_x f$$

$$= \frac{2V}{8\pi^3} \int_0^{\pi/a} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} dk_x dk_y dk_z \frac{\hbar k_x}{m} f$$



Electron Flux Out of Surface

$$\begin{aligned} J_p &= \frac{2}{8\pi^3} \int_0^{\pi/a} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} dk_x dk_y dk_z \frac{\hbar k_x}{m} \frac{1}{\exp\left(\frac{E - \mu}{k_B T}\right) + 1} \\ &\approx \frac{2}{8\pi^3} \int_0^{\pi/a} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} dk_x dk_y dk_z \frac{\hbar k_x}{m} \exp\left(-\left[W + \frac{\hbar^2(k_x^2 + k_y^2 + k_z^2)}{2m}\right] \frac{1}{k_B T}\right) \\ &= \frac{m}{2\pi^2 \hbar^3} (k_B T)^2 \exp\left(-\frac{W}{k_B T}\right) \end{aligned}$$

Electrical Current Density

$$J_e = \frac{em}{2\pi^2\hbar^3} (k_B T)^2 \exp\left(-\frac{W}{k_B T}\right) = AT^2 \exp\left(-\frac{W}{k_B T}\right)$$



O.W. Richardson
1928 Nobel Prize

**Richardson Formula or
Richardson-Dushman Equation
For Thermionic Emission**

$$A = \frac{emk_B^2}{2\pi^2\hbar^3} = 120 \frac{A}{cm^2 K^2}$$

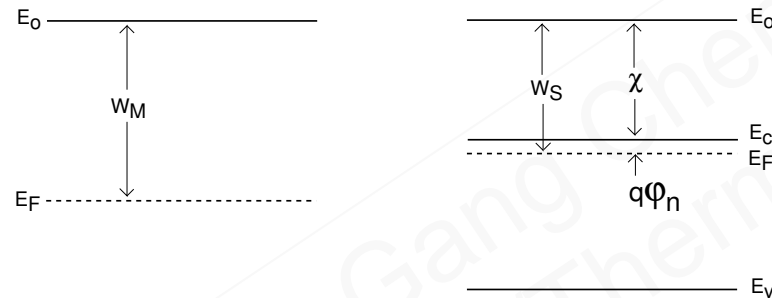
Richardson Constant

$$J_e = (1-r)AT^2 \exp\left(-\frac{\phi}{k_B T}\right)$$

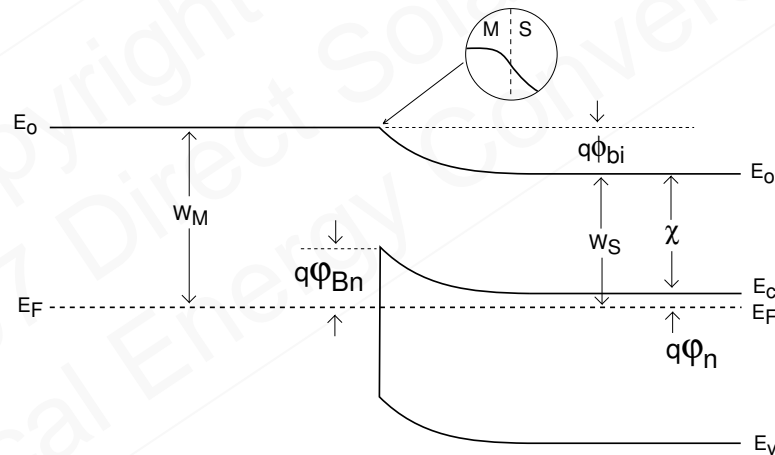
More General

Contact Potential

$$W_S = \chi + q\phi_n$$



a) metal and semiconductor far apart



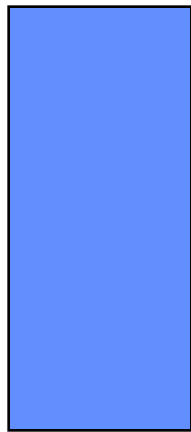
b) metal and semiconductor in intimate contact

$$-e(\phi - \phi') = W - W' = -eV_c$$

Courtesy of Jesús del Alamo. Used with permission.

Vacuum Diode

Cathode

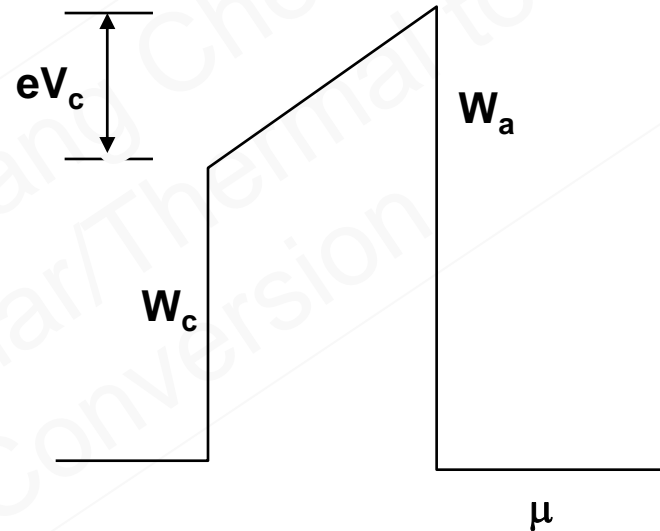


Anode



J_a

J_c



$$J_c = AT^2 \exp\left(-\frac{W_c + eV_c}{k_B T}\right)$$

$$J_a = AT^2 \exp\left(-\frac{W_a}{k_B T}\right)$$

$$-eV_c = (W_a - W_c)$$

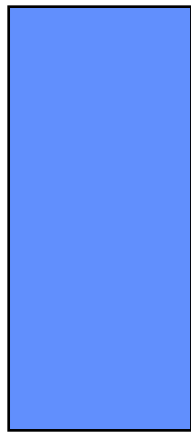
At equilibrium,

$$J = J_c - J_a = 0$$

Thermionic Generator

$$T_c > T_a$$

Cathode T_c

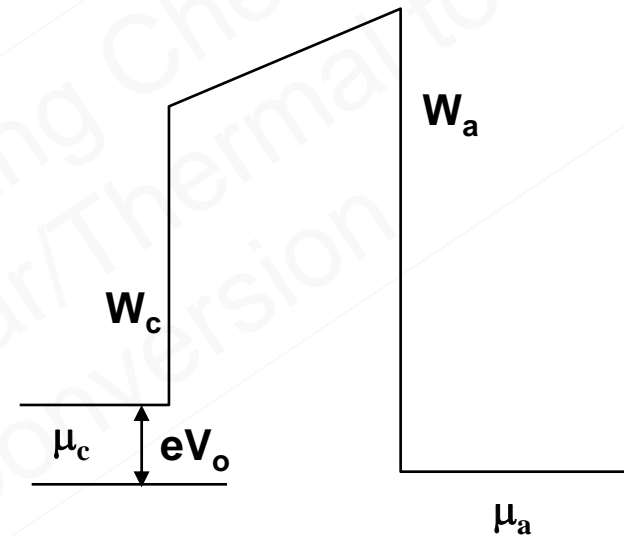


Anode T_a



J_a

J_c



$$J_c = AT_c^2 \exp\left(-\frac{W_c + eV_c + eV_o}{k_B T_c}\right)$$

$$-eV_o = \mu_a - \mu_c$$

At equilibrium,

$$J_a = AT_a^2 \exp\left(-\frac{W_a}{k_B T_a}\right)$$

$$J = J_c - J_a = 0$$

Thermionic Generator

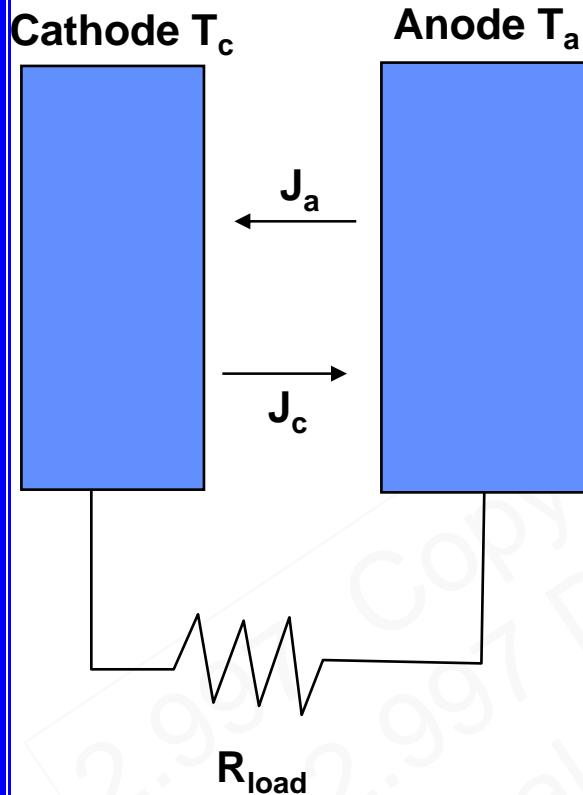
$$AT_c^2 \exp\left(-\frac{W_c + eV_c + eV_o}{k_B T_c}\right) - AT_a^2 \exp\left(-\frac{W_a}{k_B T_a}\right) = 0$$

$$2 \ln\left(\frac{T_c}{T_a}\right) = \frac{W_c + eV_c + eV_o}{k_B T_c} - \frac{W_a}{k_B T_a}$$

Open Circuit Voltage:

$$V_o = \frac{W_a}{e} \left(\frac{T_c}{T_a} - 1\right) + 2 \frac{k_B T_c}{e} \ln\left(\frac{T_c}{T_a}\right)$$

Under Operation



$$J = AT_c^2 \exp\left(-\frac{W_c + eV_c + eV}{k_B T_c}\right) - AT_a^2 \exp\left(-\frac{W_a}{k_B T_a}\right)$$
$$= AT_c^2 \exp\left(-\frac{W_a + eV}{k_B T_c}\right) - AT_a^2 \exp\left(-\frac{W_a}{k_B T_a}\right)$$

Power Output

$$P = JV$$

Heat Transfer: Electron Heat Flux

Kinetic Energy:

$$J_{k,c} = \frac{2}{8\pi^3} \int_0^{\pi/a} \int_{-\pi/a}^{\pi/a} \int_{-\pi/a}^{\pi/a} dk_x dk_y dk_z \left(\frac{\hbar^2 k_x^2}{2m} \right) \frac{1}{\exp\left(\frac{E - \mu}{k_B T}\right) + 1}$$

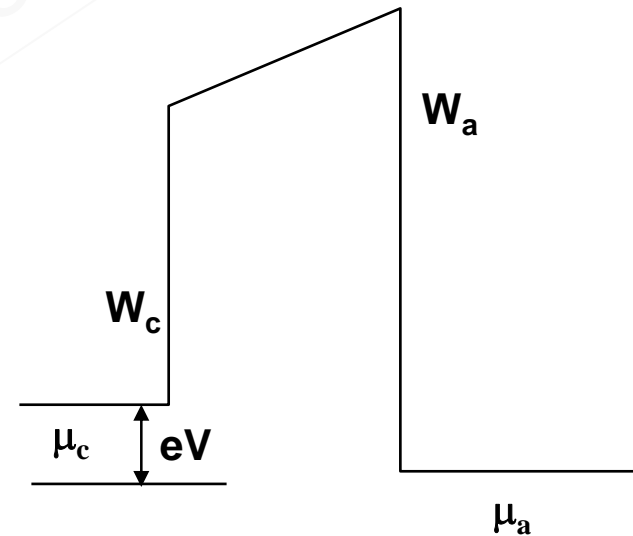
$$= \frac{2k_B T_c}{e} J_c$$

Total Heat from Cathode to Anode:

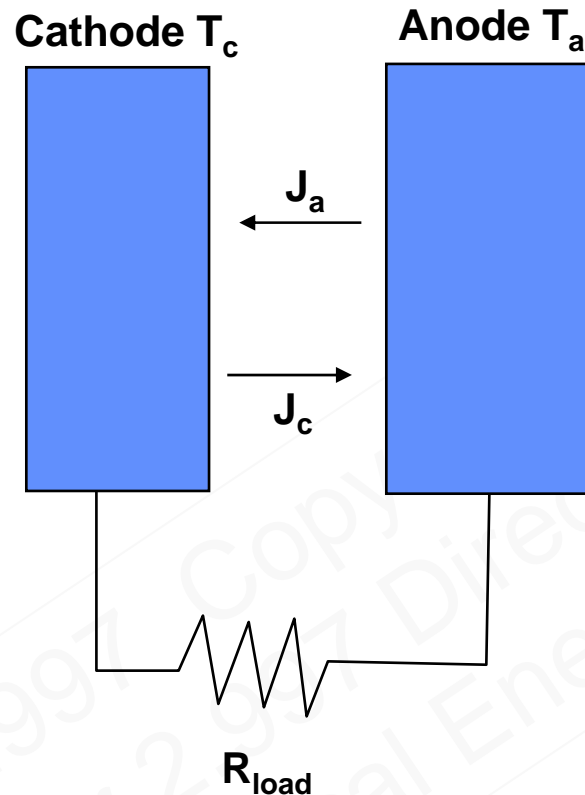
$$J_{q,c} = \left(\frac{W_a}{e} - V + \frac{2k_B T_c}{e} \right) J_c$$

Total Heat from Cathode to Anode:

$$J_{q,a} = \left(\frac{W_a}{e} + \frac{2k_B T_a}{e} \right) J_a$$



Net Heat Input



$$Q_h = J_{q,c} - J_{q,a} + Q_{rad} + Q_{cond}$$

Q_{rad} --- Radiation heat transfer between cathode and anode

Q_{cond} --- Conduction heat loss through leads, and gas in between

Efficiency

$$\eta = \frac{\text{Power}}{Q_h}$$

When radiation is neglected



$$eV_a = W_a$$

S.W. Angrist,
Direct Energy Conversion,
Allyn and Bacon, Boston, 1965

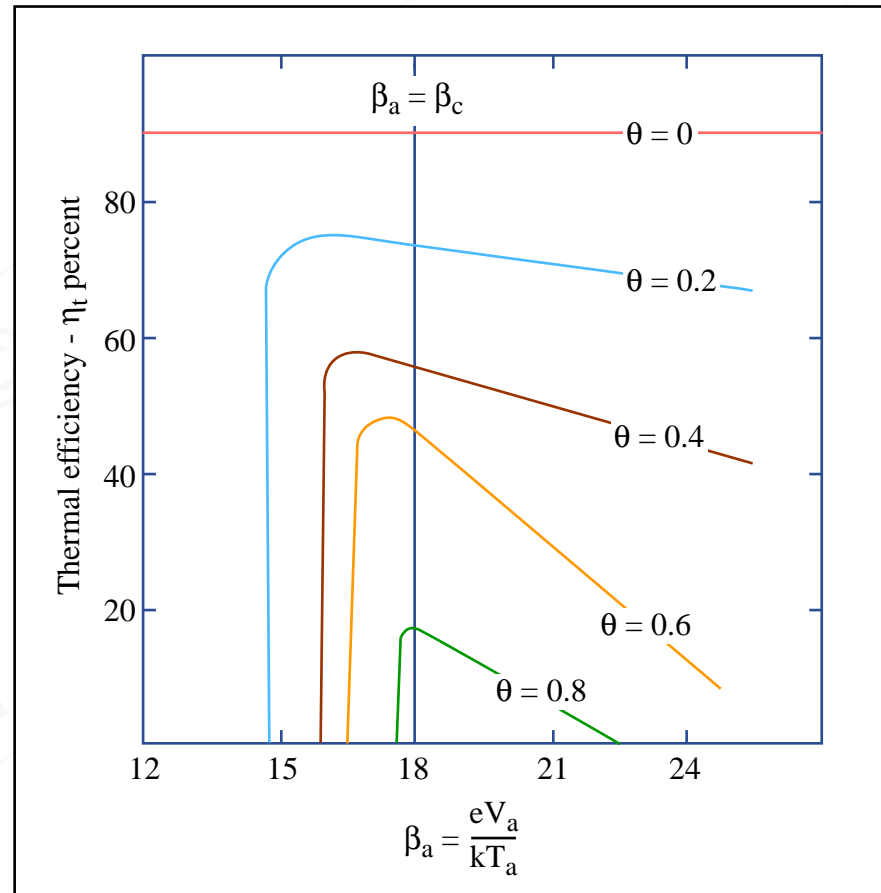


Figure by MIT OpenCourseWare.

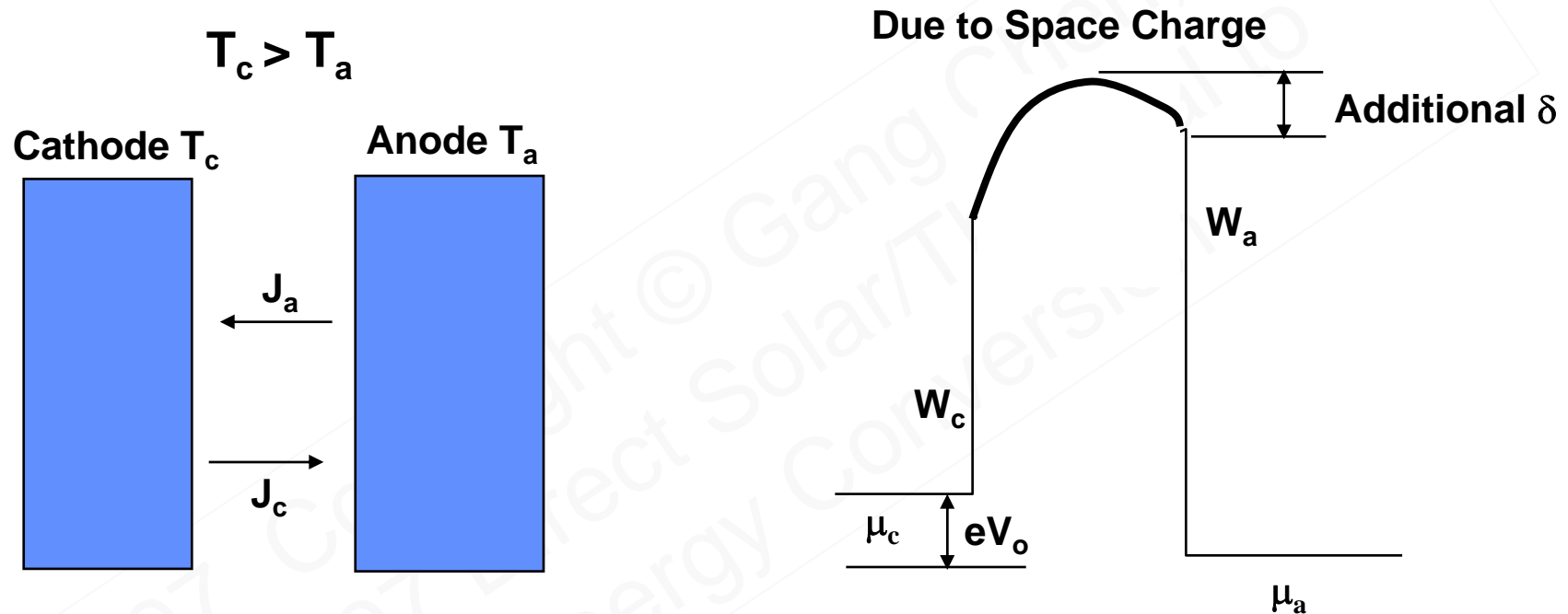
Experimental Demonstration

Image removed due to copyright restrictions.

Please see Fig. 3 in Hatsopoulos, George N., and Joseph Kaye. "Measured Thermal Efficiencies of a Diode Configuration of a Thermo Electron Engine." *Journal of Applied Physics* 29 (1958): 1124-1125.

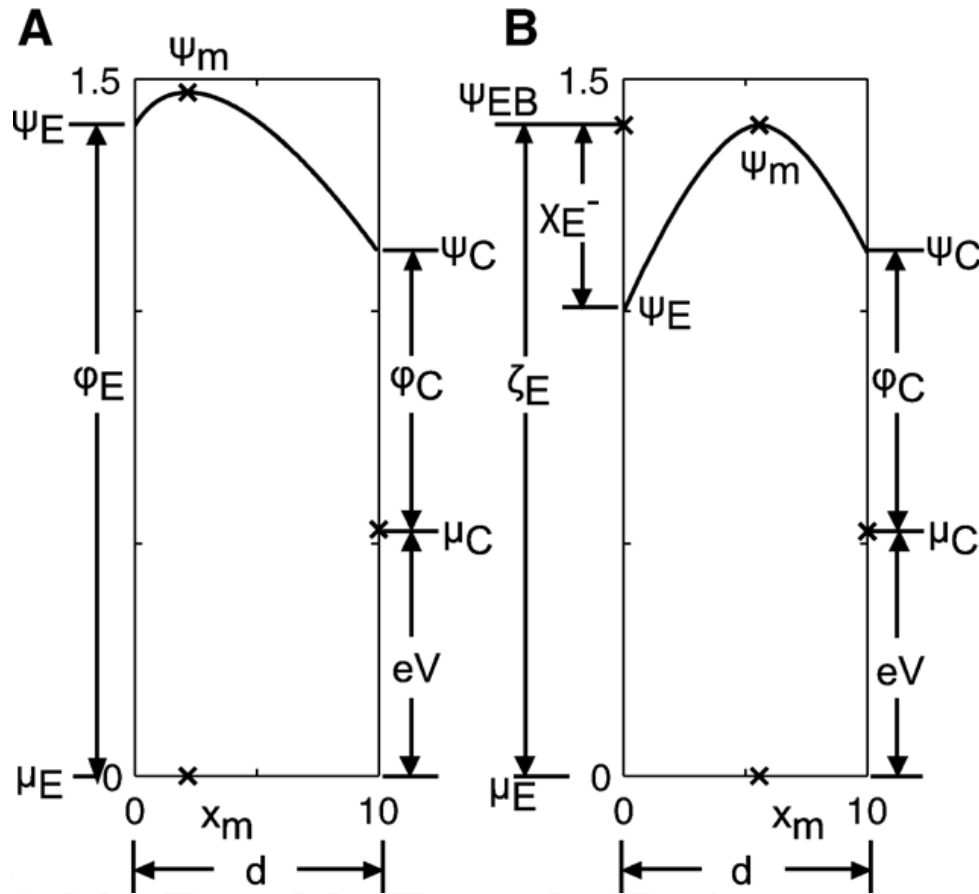
Hatsopoulos and Kaye, JAP, 1958.

Real Device Issues



- Large work function, high temperature
- Cesium to reduce space charge, but reliability problem
- Vacuum operation or plasma operation (filled with gas)

Recent Trends



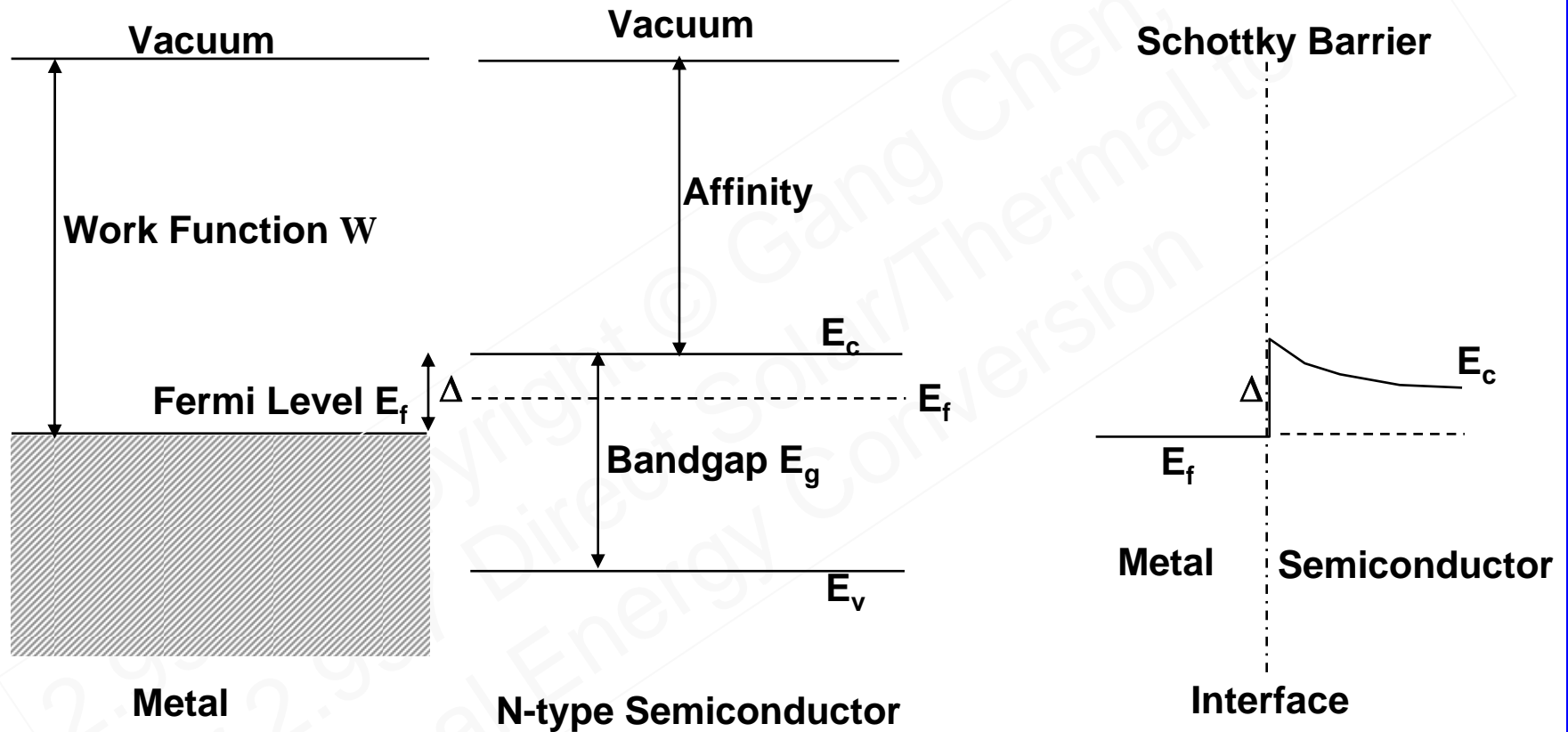
**Negative Electron Affinity Materials
(Diamond)**

Smith et al., Diamond and related materials, 15, 2082 (2006)

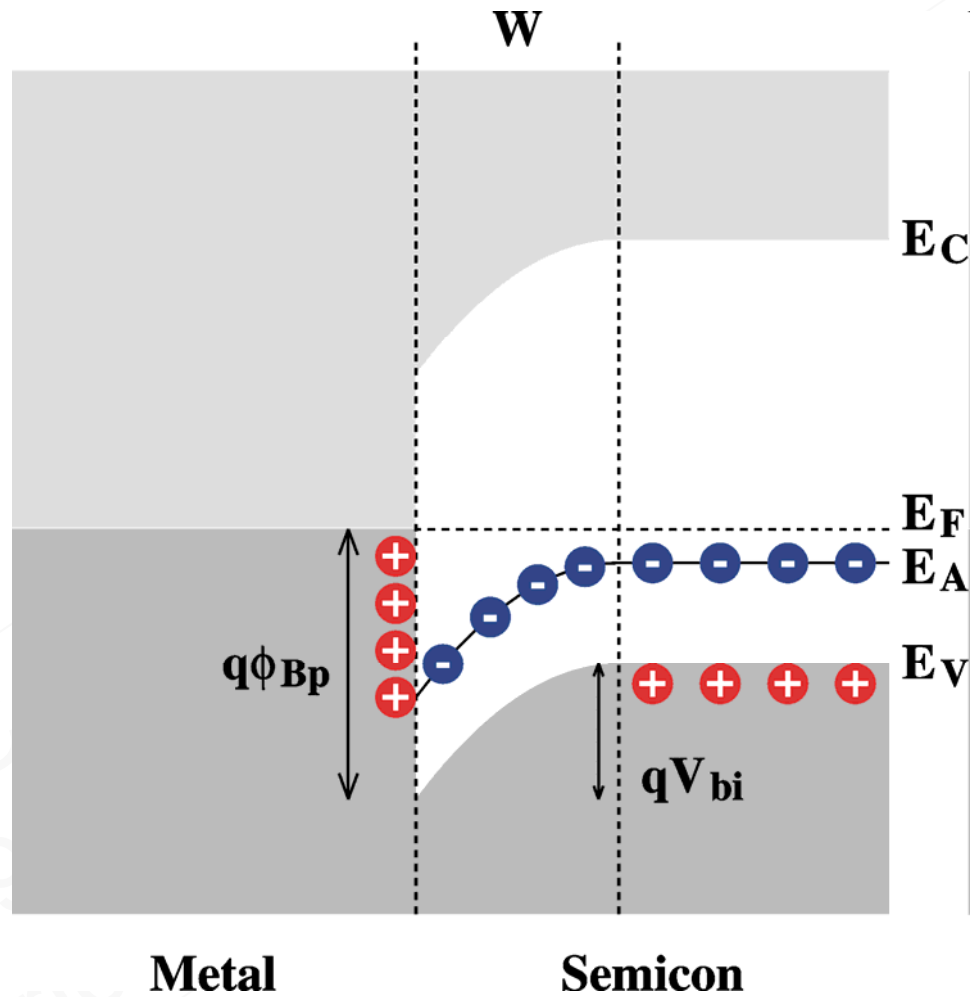
- **Negative electron affinity materials**
- **Small gap devices**
- **Solid-state thermionics**

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Schottky Barrier



P-type Schottky Barrier



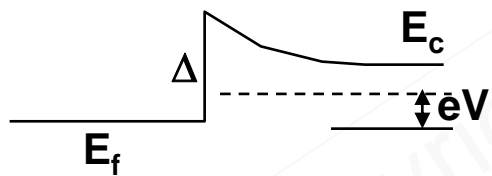
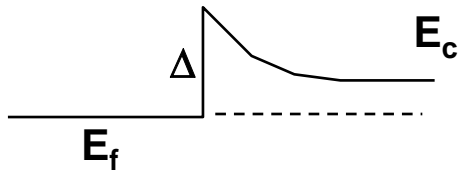
<http://w3.ualg.pt/~pjotr/Images/Schottky.png>

Courtesy of Peter Stallinga. Used with permission.

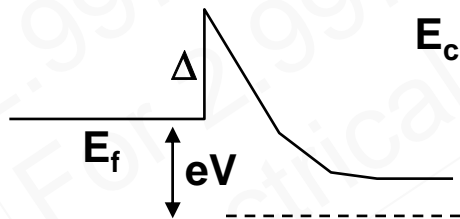
Schottky Diode

Richardson Formula

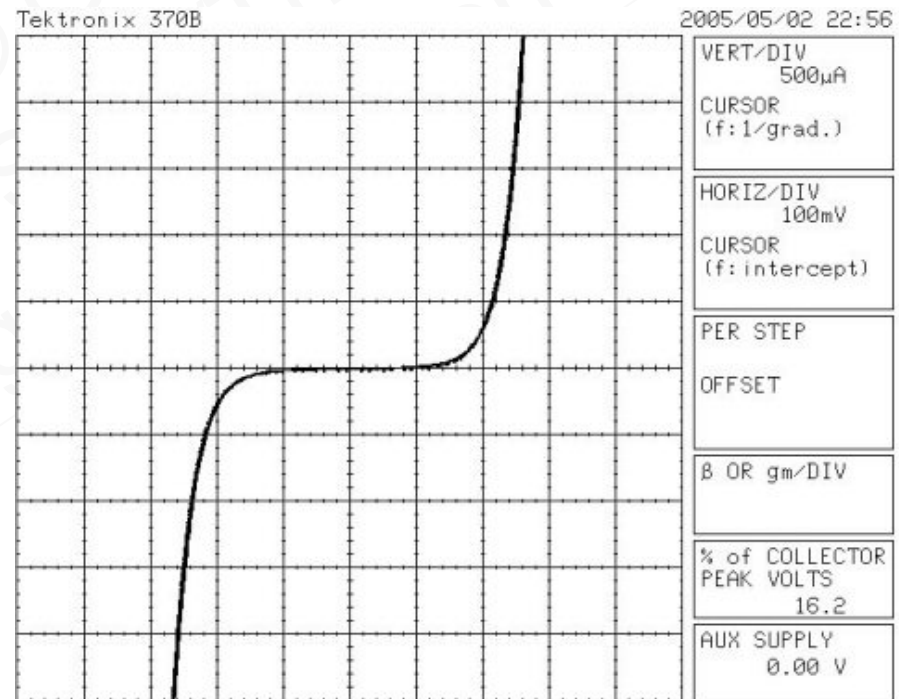
$$J = AT^2 \exp\left(-\frac{\Delta}{k_B T}\right) \left[\exp\left(\frac{eV}{k_B T}\right) - 1 \right]$$



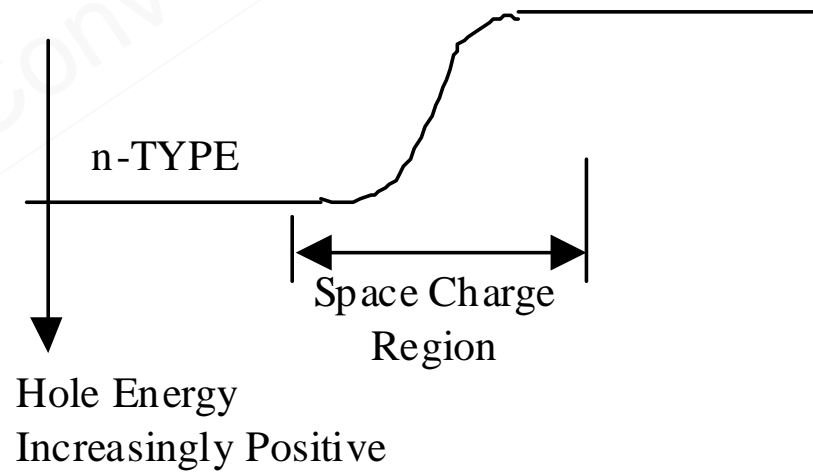
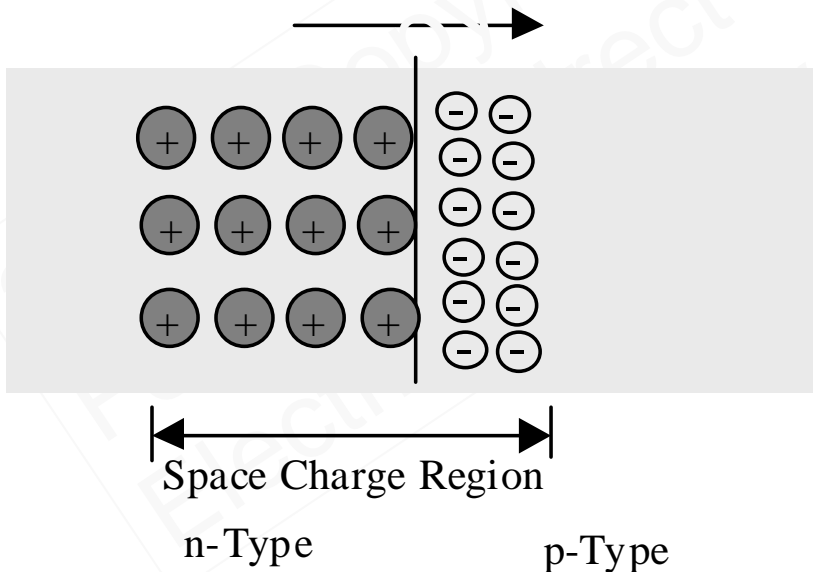
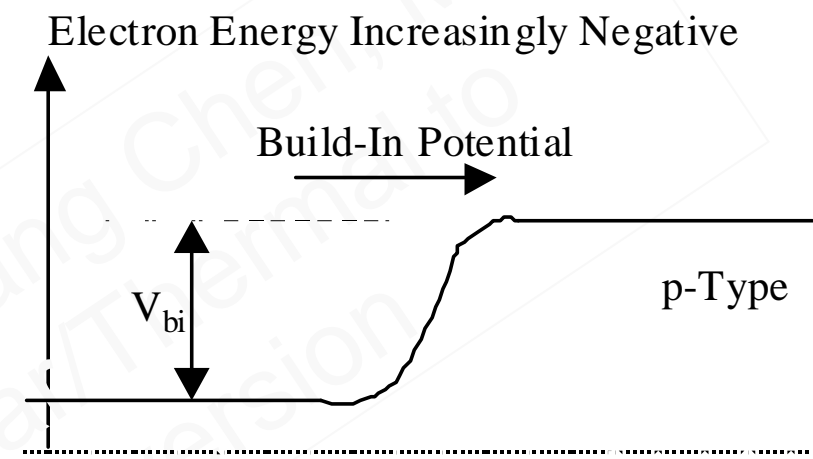
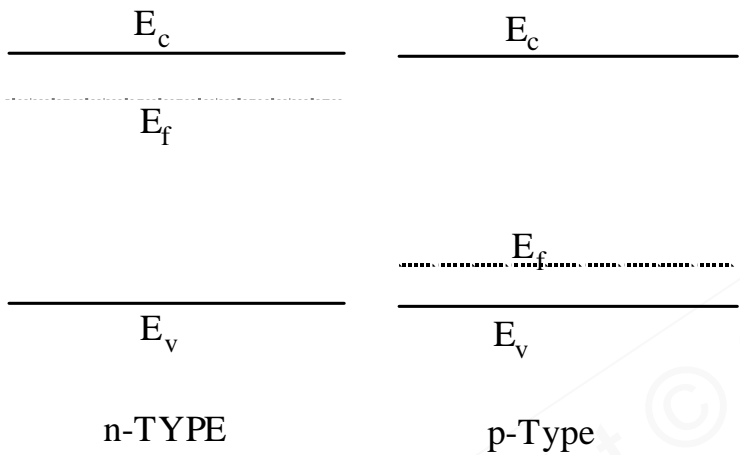
Forward Bias



Reverse Bias



pn Junction



pn Junction Basics

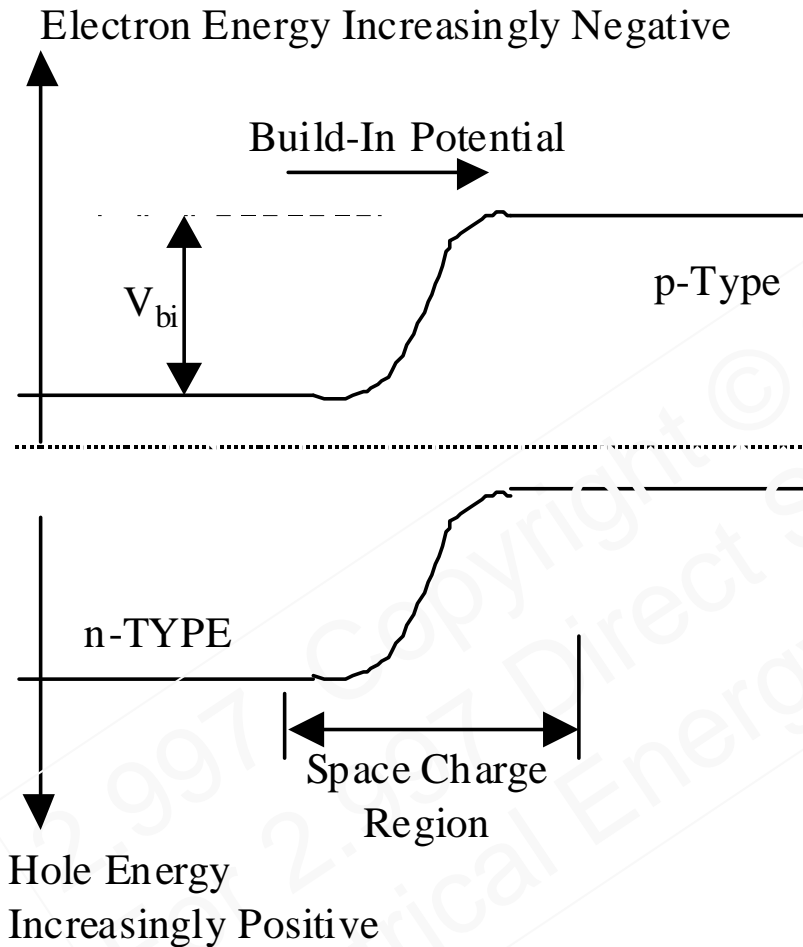
- For nondegenerate semiconductor

$$n = N_c \exp\left(-\frac{E_c - \mu}{k_B T}\right)$$

$$p = N_v \exp\left(-\frac{\mu - E_v}{k_B T}\right)$$

$$pn = N_c N_v \exp\left(-\frac{E_g}{k_B T}\right) = n_i^2$$

pn Junction Basics: Built-in Potential



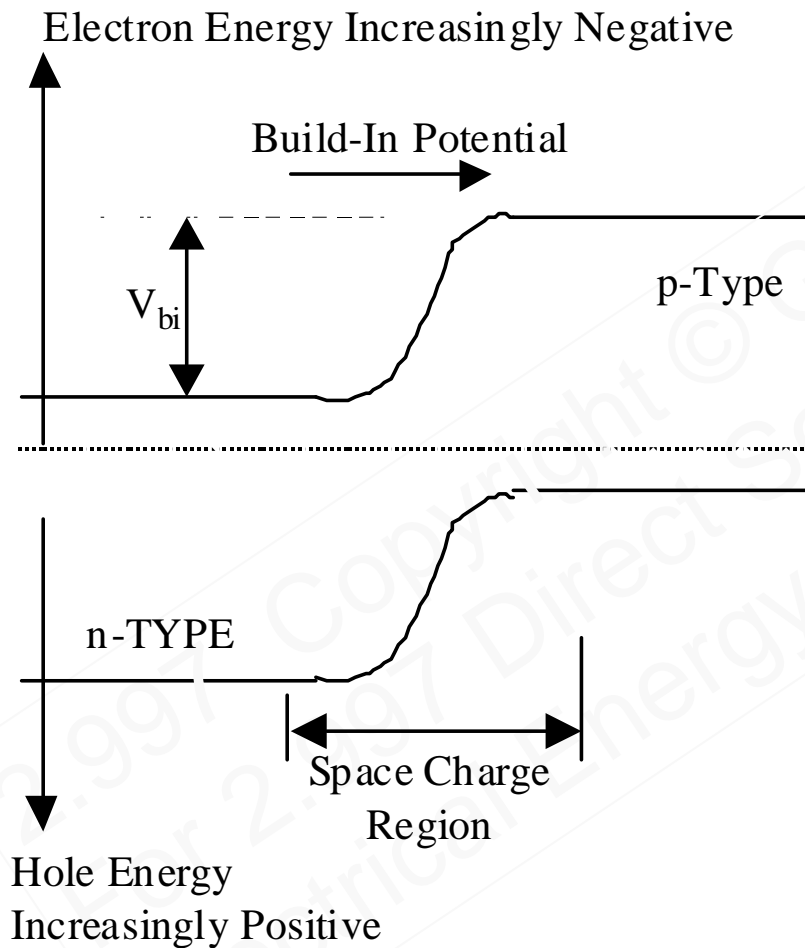
$$N_D = N_c \exp\left(-\frac{E_{c,n} - \mu}{k_B T}\right)$$

$$E_{c,n} - \mu = k_B T \ln\left(\frac{N_c}{N_D}\right)$$

$$E_{c,p} - \mu = E_g - k_B T \ln\left(\frac{N_v}{N_A}\right)$$

$$eV_{bi} = E_{c,p} - E_{c,n} = E_g - k_B T \ln\left(\frac{N_v N_c}{N_A N_D}\right) = k_B T \ln\left(\frac{N_A N_D}{n_i^2}\right)$$

pn Junction Basics: Space Charge Region



$$w = \sqrt{\frac{2\epsilon_s}{e} \left(\frac{N_A + N_D}{N_A N_D} \right) V_{bi}}$$

One Side Only

$$w = \sqrt{\frac{2\epsilon_s}{eN_B} V_{bi}}$$

Debye Length

$$w = \sqrt{\frac{2\epsilon_s}{e^2 N_B} k_B T}$$

pn Junction I-V

$$J = J_s \left(e^{eV/k_B T} - 1 \right)$$

Saturation Current

$$J_s = eN_c N_v \left(\frac{1}{N_A} \sqrt{\frac{a_h}{\tau_h}} + \frac{1}{N_D} \sqrt{\frac{a_e}{\tau_e}} \right) \exp\left(-\frac{E_G}{k_B T} \right)$$

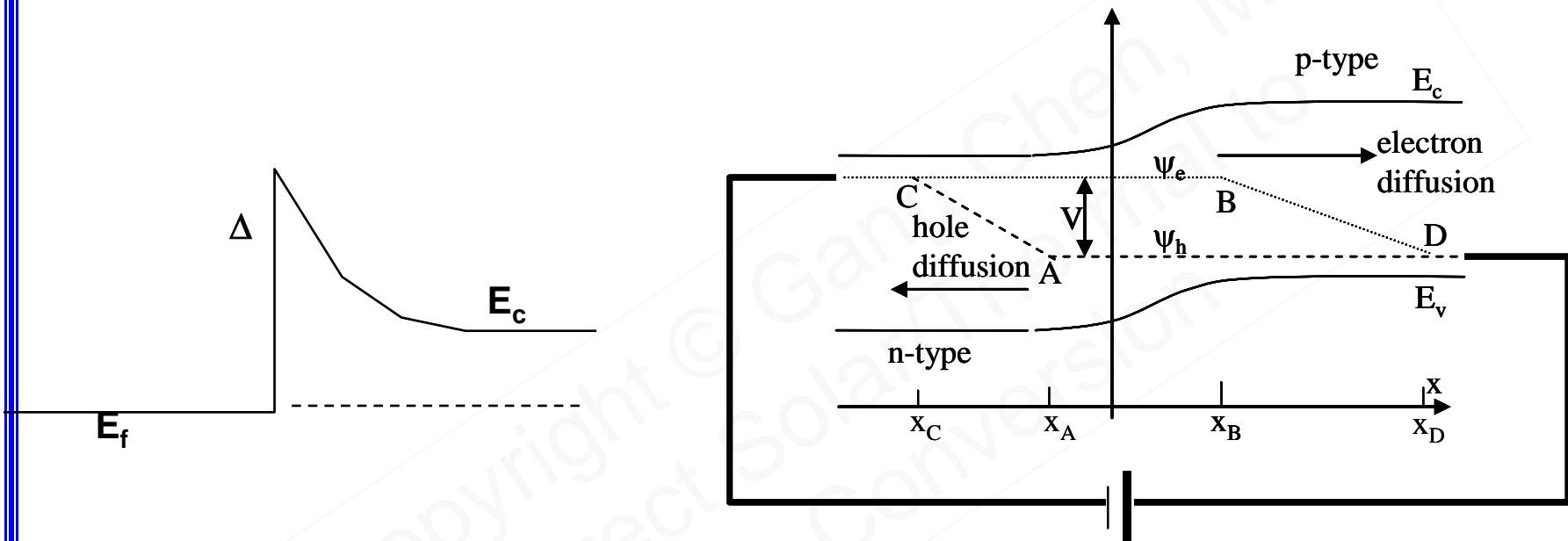
a_h ---hole diffusivity (m²/s)

a_e ---electron diffusivity

τ_h ---hole recombination time

τ_e ---electron recombination time

Compare Schottky diode and pn diode



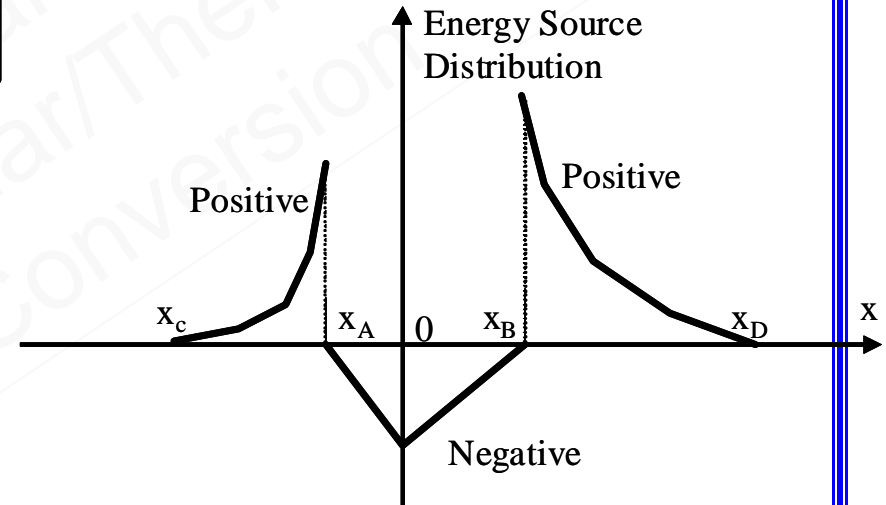
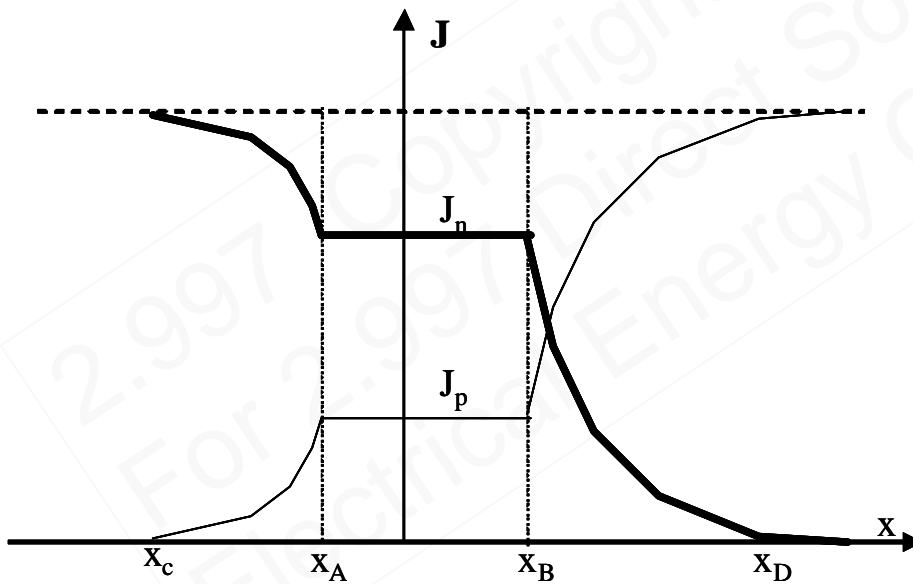
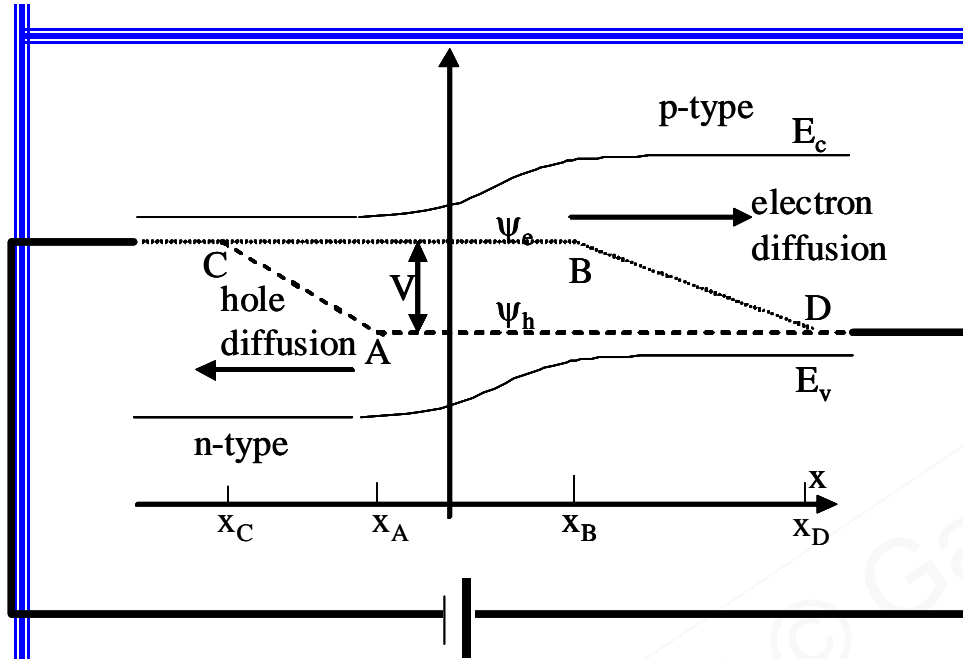
$$J = J_s \left[\exp\left(\frac{eV}{k_B T}\right) - 1 \right]$$

$$J_s = AT^2 \exp\left(-\frac{\Delta}{k_B T}\right)$$

$$J = J_s \left(e^{eV/k_B T} - 1 \right)$$

$$J_s = eN_c N_v \left(\frac{1}{N_A} \sqrt{\frac{a_h}{\tau_h}} + \frac{1}{N_D} \sqrt{\frac{a_e}{\tau_e}} \right) \exp\left(-\frac{E_G}{k_B T}\right)$$

Current and Energy Distribution



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2.997 Direct Solar/Thermal to Electrical Energy Conversion Technologies
Fall 2009

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